



Attorney Docket No. 0756-7197

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koichiro TANAKA

Serial No. 10/664,916

Filed: September 22, 2003

For: BEAM HOMOGENIZER AND LASER
IRRADIATION APPARATUS AND
METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE

) Group Art Unit: 1722

) Examiner: Robert M. Kunemund

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is
) being deposited with the United States Postal
) Service with sufficient postage as First Class
) Mail in an envelope addressed to:
) Commissioner for Patents, P.O. Box 1450,
) Alexandria, VA 22313-1450, on June 19,
) 2006.

Rose Eichler

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated March 17, 2006, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 15 of this paper.